



AF/2800

10/Q (N.E.)
G. Stanley
6-13-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Haruo Hyodo et al.
Serial No. : 09/963,839
Filed : September 26, 2001
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Art Unit : 2818
Examiner : Quoc Dinh Hoang

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY

In reply to the action mailed March 5, 2003, please amend the application as indicated on the following pages. Applicant asks that all claims be allowed in view of the amendment to the claims and remarks contained on the following sheets, a total of 5 pages.

Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: June 5, 2003

Arthur Ortega
Arthur Ortega
Reg. No. 53,422

Fish & Richardson P.C.
45 Rockefeller Plaza, Suite 2800
New York, New York 10111
Telephone: (212) 765-5070
Facsimile: (212) 258-2291

30149807.doc

RECEIVED
JUN 11 2003
TECHNOLOGY CENTER 2800

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

JUNE 5, 2003
Date of Deposit
Patricia F. Suchanek
Signature
PATRICIA F. SUCHANEK
Typed or Printed Name of Person Signing Certificate